

Attorney Docket No. 071469-0307699  
Client Reference: ES-040

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inde application of: HONGYU YUE

Application No.: 10/812,355

Confirmation

4102

No:

Filed: March 30, 2004

Group No.: 1742

Examiner Not Yet Assigned

For: METHOD AND SYSTEM FOR ADJUSTING A CHEMICAL OXIDE REMOVAL  
PROCESS USING PARTIAL PRESSURE

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**SUPPLEMENTAL APPLICATION DATA SHEET**  
**37 C.F.R. § 1.76**

**BIBLIOGRAPHIC DATA**

**1. Applicant information**

First applicant: HONGYU YUE  
Citizenship: PEOPLES' REPUBLIC OF CHINA  
Residence: Plano, TX 75025

**2. Correspondence information**

Correspondence for this application should be addressed as follows:

Customer No.: 00909

**3. Application information**

Title of Invention: METHOD AND SYSTEM FOR ADJUSTING A CHEMICAL OXIDE  
REMOVAL PROCESS USING PARTIAL PRESSURE

Docket number assigned to this application: 071469-0307699

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 22

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

**4. Representative information**

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

**5. Assignee information**

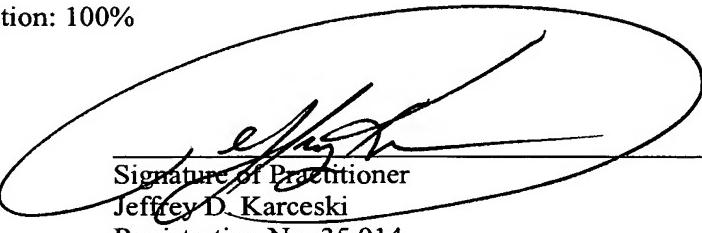
The assignee(s) of this application is/are:

Tokyo Electron Limited  
3-6, Akasaka 5-chome, Minato-ku  
Tokyo, 107  
JAPAN

Extent of interest of assignee in application: 100%

Date: September 9, 2004

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